

CLAIMS

1. A method for manufacturing plasma display panels (PDP) including a step of forming a film on a substrate with the substrate held by a substrate holder,

wherein when a film is formed, the substrate holder is repeatedly used, and in the step of forming a film on a substrate, a substrate holder attached with the film due to repeated use co-exists with another substrate holder, from which the film attached is removed, in an evaporating room.

2. The method for manufacturing PDP as defined in claim 1, wherein the evaporating room contains a greater number of substrate holders attached with the film due to repeated use than a number of substrate holders from which the film attached is removed.

3. The method for manufacturing PDP as defined in claim 2, wherein the substrate holder includes a plurality of elements, and the substrate holder from which the film attached is removed refers to a substrate holder of which at least one of the elements is removed the film attached.

4. The method for manufacturing PDP as defined in claim 3, wherein the plurality of elements include a frame retaining the substrate and a dummy substrate retained by another frame, and the film attached is removed from the dummy substrate.